

Substitute Form PTO-1449 (Modified)  <b>Information Disclosure Statement by Applicant</b> (Use several sheets if necessary)  (37 CFR §1.98(b))	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 07977-279001	Application No. 09/892,225
	Applicant Shunpei Yamazaki, et al.		
	Filing Date June 25, 2001	Group Art Unit 1722	

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
MS	AA	5,932,893	08/03/1999	Miyanaaga et al.			02/03/1998
	AB	5,943,560	08/24/1999	Chang et al.			04/19/1996
	AC	5,977,560	11/02/1999	Banerjee et al.			05/09/1997
	AD	6,087,679	07/11/2000	Yamazaki et al.			07/22/1998
	AE	6,107,654	08/22/2000	Yamazaki			02/08/1999
	AF	6,307,214	10/23/2001	Ohtani et al.			05/27/1998
	AG	6,307,220	10/23/2001	Yamazaki			08/05/1998
	AH	6,335,541	01/01/2002	Ohtani et al.			04/15/1996
	AI	6,346,716	02/12/2002	Yamazaki			12/19/1997
	AJ	6,452,211	09/17/2002	Ohtani et al.			06/09/1998
	AK	6,495,886	12/17/2002	Yamazaki et al.			06/13/2000
	AL	6,610,996	08/26/2003	Yamazaki et al.			08/27/2001
	AM	6,690,068	02/10/2004	Yamazaki et al.			06/06/2001
	AN	6,693,044	02/17/2004	Yamazaki et al.			01/08/1999
	AO	6,787,807	09/07/2004	Yamazaki et al.			06/18/2001
	AP	6,828,587	12/07/2004	Yamazaki et al.			06/14/2001
	AQ	6,956,235	10/18/2005	Yamazaki et al.			04/29/2004
	AR	2002/0008286	01/24/2002	Yamazaki et al.			06/06/2001
	AS	2002/0038889	04/04/2002	Yamazaki et al.			06/18/2001
	AT	2002/0043662	04/18/2002	Yamazaki et al.			06/14/2001
	AU	2004/0108576	06/10/2004	Yamazaki et al.			12/05/2003
MS	AV	2004/0201022	10/14/2004	Yamazaki et al.			04/29/2004

Foreign Patent Documents or Published Foreign Patent Applications								
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AW							
	AX							

Examiner Signature  /Matthew Song/	Date Considered  09/15/2006
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 07977-279001	Application No. 09/892,225
<b>Information Disclosure Statement by Applicant</b> (Use several sheets if necessary)  (37 CFR §1.98(b))		Applicant Shunpei Yamazaki, et al.	
		Filing Date June 25, 2001	Group Art Unit 1722

Foreign Patent Documents or Published Foreign Patent Applications								
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AY							
	AZ							
	AAA							

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
MS	ABB	Haji et al., "Mode of Growth and Microstructure of Polycrystalline Silicon Obtained by Solid-Phase Crystallization of an Amorphous Silicon Film," J. Appl. Phys. 75 (8), April 15, 1994, pages 3944-3952.
MS	ACC	Hayzelden et al., "Silicide Formation and Silicide-Mediated Crystallization of Nickel-Implanted Amorphous Silicon Thin Films," J. Appl. Phys. 73 (12), June 15, 1993, pages 8279-8289.
	ADD	
	AEE	

Examiner Signature /Matthew Song/	Date Considered 09/15/2006
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	